



Physical Interfaces & Carriers North America TC Chapter

NA Standards Fall Meetings 2023

Wednesday, November 8

SEMI Headquarters, Milpitas, California/USA

10:00–12:00 Noon Pacific (OVTCCM)

AGENDA

	Time
1 Welcome/Call to Order	10:00
1.1 Log into SVM for voting (https://svm.semi.org/)	
1.2 Agenda Review	
1.3 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)	
1.4 Introductions	
2 Review of Previous Meeting Minutes	10:10
3 Liaison Report (Japan)	10:15
4 Staff Report	10:20
5 Ballot Review (no ballots)	
6 Subcommittee & Task Force Reports	10:25
6.1 Electron Microscopy Workflow Task Force	
6.2 SEMI E72 Revision Task Force	
6.3 Film Frame FOUP Task Force (<i>did not meet</i>)	
6.4 Global PIC Maintenance Task Force (<i>did not meet</i>)	
7 Break? (10 minute)	11:10



	Time
8 Old Business	11:20
8.1 Revisit Infineon Proposal on Integrated Workflows in Failure Analysis – TFOF/SNARF approval	
8.2 Film Frame FOUP – new SNARF approval	
8.3 SEMI E72 Revision – new SNARF approval	
9 New Business	11:25
10 Action Item Review	11:50
11 Next Meeting and Adjournment	11:55
11.1 The next meeting is tentatively scheduled for the week of March 25-28, in conjunction with NA Standards Spring Meetings 2024. Schedule details TBD. Please check www.semi.org/standards for updates.	

Tentative Schedule:

Tuesday, March 26

- 13:00-16:00 (*tentative*), Film Frame FOUP TF
- 15:00-16:00, Electron Microscopy Workflow TF
- 16:00-17:00, SEMI E72 Revision TF

Wednesday, March 27

- 09:00-10:00, Global PIC Maintenance TF
- 10:00-12:00 Noon, PIC NA TC Chapter Meeting

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STANDARDS VIRTUAL MEETING INFORMATION LINK

<https://www.semi.org/en/semi-standards-fall-2023-meetings-virtual-information>

NOTE:

Standards meetings are open to all, but you must be a SEMI Standards Program Member to attend.

If you are not a member, please register for the International SEMI Standards Program here:

<https://www.semi.org/standardsmembership>